

Electronic Acknowledgement Receipt

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Title of Invention:	Method of depositing low k films
First Named Inventor:	Tzu-Fang Huang
Customer Number:	44257
Filer:	Keith M. Tackett/Tammi Thomas
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File Listing:

Document Number	Document Description	File Name	File Size(Bytes)	Multi Part	Pages
1	Amendment After Final	002592C8_SECOND_RFOA_EF.pdf	276854	no	7

Warnings:	
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